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Docket No. 8733.913.00
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Sang-Hyun KIM

Customer No. 30827

Application No. 10/663,805

Confirmation No. 3765

Filed: September 17, 2003

Art Unit: 1763

For: FABRICATION METHOD OF
POLYCRYSTALLINE SILICON TFT

Examiner: George A. Goudreau

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the final Office Action dated March 17, 2006, please amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.